



Docket No.: 57454-470

PATENT

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IDS  
RABep  
10/30/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Application of

Eiichi MIYAKE ✓

Serial No.: 10/069,067 ✓

Filed: February 21, 2002 ✓

For: BOARD SUPPORTING STAGE FOR EXPOSURE SYSTEM

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Group Art Unit: 3632  
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Examiner: not yet assigned

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SEP 26 2002  
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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
Washington, DC 20231

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JUN 26 2002  
GROUP 3600

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

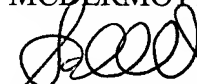
To ensure that these references are available to the Examiner we are providing copies. Acknowledgement and consideration of these documents are respectfully requested.

10/069,067

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY



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